



Attorney's Docket No.: 07977-010004 / US2941D1D1

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto et al.

Art Unit : 2814

Serial No. : 09/903,339

Examiner : Theresa T. Doan

Filed : July 10, 2001

Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM
SEMICONDUCTOR DEVICE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

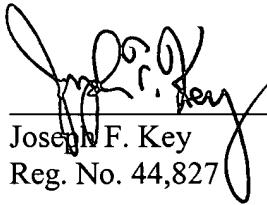
REQUEST FOR INITIALED PTO FORM 1449

Upon reviewing the file, applicants noted that they have not received an initialed copy of the enclosed PTO Form 1449 that accompanied an information disclosure statement filed July 1, 2003. Also enclosed is a copy of the date-stamped postcard.

Applicants' records show that this information disclosure statement complied with 37 CFR 1.97. Thus, we respectfully request that the examiner initial and return this form as soon as possible.

Respectfully submitted,

Date: 12/16/2003


Joseph F. Key
Reg. No. 44,827

Fish & Richardson P.C.
1425 K Street, N.W.
11th Floor
Washington, DC 20005-3500
(202) 783-5070 telephone
(202) 783-2331 facsimile

Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce DEC 16 2001 Patent and Trademark Office	Attorney's Docket No. 07977-010004	Application No. 09/903,339
Information Disclosure Statement by Applicant <small>(Use several sheets if necessary)</small> <small>(37 CFR §1.98(b))</small>		Applicant Kusumoto et al.		
		Filing Date July 10, 2001	Group Art Unit 2814	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,569,610	10/29/96	Zhang et al.			
	AB	6,413,805	07/02/02	Zhang et al.			
	AC	6,458,200	10/01/02	Zhang			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AL	04-37144	07 FEB 1992	JAPAN			Abstract
	AM	06-267989	22 SEP 1994	JAPAN			Abstract
	AN	06-318701	15 NOV 1994	JAPAN			Abstract
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

JFH/WXH/adt

Attorney's Docket No. 07977-010004	Express Mail Label No.	Mailing Date July 1, 2003	For PTO Use Only <i>Do Not Mark in This Area</i>
Application No. 09/903,339	Filing Date July 10, 2001	Attorney/Secretary Init JFH/WXH/adt	
Title of the Invention METHOD FOR PRODUCING INSULATED GATE THIN FILM SEMICONDUCTOR DEVICE			
Applicant Kusumoto et al.			
Enclosures • Check in the amount of \$180.00 <i>CR# 167404</i> • Information Disclosure Statement (1 page) • Form PTO-1449 (1 page) • Documents listed on the Form PTO-1449 (6)			

CR# 167404

CJL

JUL 01 2003

JC34

U.S. PATENT & TRADEMARK OFFICE